



ASSIGNMENT

WHEREAS, I, Kenichi OGATA of No.200 Oonakazato, Fujinomiya-shi, Shizuoka, Japan

have invented certain new and useful improvements in METHOD AND APPARATUS FOR INSPECTING PHOTSENSITIVE MATERIAL FOR SURFACE DEFECTS

for which I am about to make application for Letters Patent of the United States of America;

AND WHEREAS, Fuji Photo Film Co., Ltd. of No.210 Nakanuma, Minami-Ashigara-shi, Kanagawa, Japan

desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor from the United States;

NOW THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.-)

to me in hand paid, the receipt of which is hereby acknowledged I have assigned, sold, and set over, and by these presents do hereby assign, sell, and set over unto the said Fuji Photo Film Co., Ltd.

\* the full and exclusive right, title, and interest in and to the said invention, as fully set forth and described in the:

Delete inapplicable wording

- (a) specification prepared and executed by me on the 7th day of October, 2002
(b) application filed on the day of, Serial No.

preparatory to obtaining Letters Patent therefor; said invention, application and Letters Patent to be held and enjoyed by the said Fuji Photo Film Co., Ltd.

for its own use and behoof, and for its legal representatives, to the full end of the term for which said Letters Patent are granted, as fully and entirely as the same would have been held by me had this assignment and sale not been made.

IN TESTIMONY WHEREOF, I hereunto set my hand and affix seal at Tokyo, Japan this 7th day of October, A.D. 2002

Kenichi OGATA Kenichi Ogata (Inventor's full Signature)

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